



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Masaki KATO et al

Group Art Unit: 2851

Application No.: 09/828.914

Examiner: H. Nguyen

Filed: April 10, 2001

Docket No.: 109187

For: EXPOSURE APPARATUS, METHOD FOR MANUFACTURING THEREOF, AND

METHOD FOR MANUFACTURING MICRODEVICE

INFORMATION DISCLOSURE STATEMENT

Director of the U.S. Patent and Trademark Office Washington, D.C. 20231

Sir:

Pursuant to 37 CFR §1.56, the attention of the Patent and Trademark Office is hereby directed to the reference(s) listed on the attached PTO-1449. Unless otherwise indicated herein, one copy of each reference is attached. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the reference(s) be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

 This Information Disclosure Statement is being filed more than three months after the U.S. filing date AND after the mailing date of the first Office Action on the merits, but before the mailing date of a Final Rejection, Notice of Allowance or other action that closes prosecution (e.g., Quayle Action).

> a. Attached is our check no. 140712 in the amount of \$180.00 in payment of the fee under 37 CFR §1.17(p). Please credit or debit Deposit Account No. 15-0461 as needed to ensure consideration of the disclosed information. Two duplicate copies of this paper are attached.

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Mario A. Costantino Registration No. 33,565

Respectfully submitted

MAC/ccs

Date: March 26, 2003

OLIFF & BERRIDGE, PLC P.O. Box 19928 Alexandria, Virginia 22320 Telephone: (703) 836-6400 DEPOSIT ACCOUNT USE AUTHORIZATION Please grant any extension necessary for entry;

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